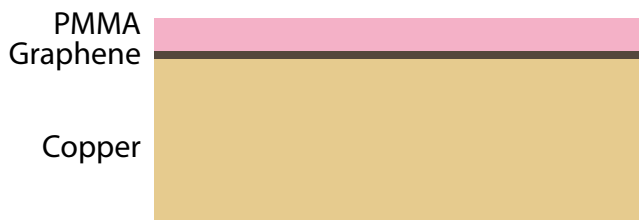




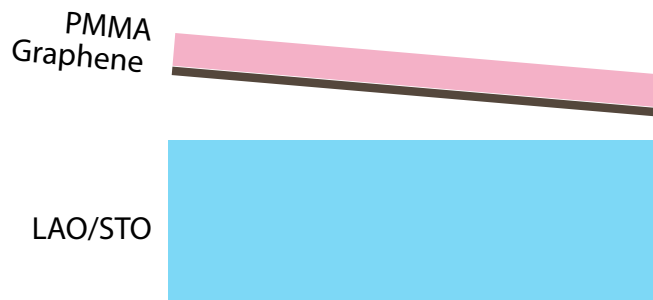
(a) CVD growth on copper



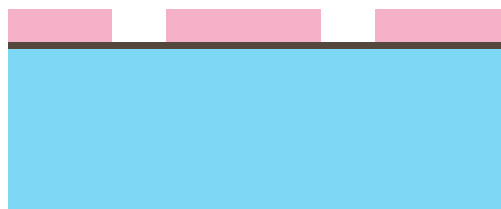
(b) PMMA spin coating



(c) Copper etching



(d) Transferring onto LAO/STO



(e) Deep-UV photolithography



(f) Remove PMMA